## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Young-Jin CHO, et al.

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BISMUTH TITANIUM SILICON OXIDE, BISMUTH

Atty. Docket No. 249/400

TITANIUM SILICON OXIDE THIN FILM, AND METHOD FOR FORMING THE THIN FILM

## REQUEST FOR WITHDRAWAL AS ATTORNEY AND CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents Alexandria, VA 22313-1450

Sir:

Please withdraw all attorneys associated with Customer Number 27849.

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Respectfully submitted,

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